

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Yonhua Tzeng Serial No.: 10/772,740 Filed: February 5, 2004 For: <b>METHOD OF PLASMA          ENHANCED CHEMICAL VAPOR          DEPOSITION OF DIAMOND          USING METHANOL-BASED          SOLUTIONS</b>	) Group Art Unit: 1792 ) ) Examiner: Stouffer, Kelly M. ) ) <b>AMENDMENT AND RESPONSE TO</b> ) <b>OFFICE ACTION MAILED</b> ) <b>October 20, 2008</b> ) ) 162 North Wolfe Road ) Sunnyvale, California 94086 ) (408) 530-9700 ) ) Customer No.: 28960
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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENTS**

Sir:

Please amend the subject application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.